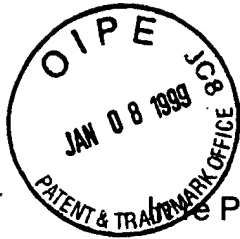


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of : Docket No. 97-CT-174
Raffaele ZAMBRANO : Group Art Unit: 2811
Serial No. 09/191,743 : Examiner: (Not assigned yet)
Filed: November 13, 1998 :
For: IN-SITU DEPOSITION AND DOPING PROCESS FOR
POLYCRYSTALLINE SILICON LAYERS AND
THE RESULTING DEVICE

REQUEST FOR CORRECTED FILING RECEIPT

Assistant Commissioner for Patents
Washington, D.C. 20231

**ATTN: Application Processing Division's
Customer Correction Branch**

Customer Correction:

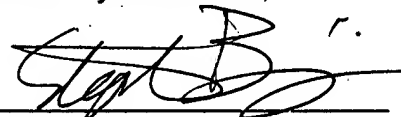
It is respectfully requested that a corrected Filing Receipt be issued in connection with the above-identified application, in order to correct the following:

Please change the Total Claims filed from "29" to --24--. A copy of the official filing receipt with the change in red is also attached.

Kindly forward the corrected Filing Receipt to the undersigned attorney of record.

Respectfully submitted,

Date: 1/4/99

By: 
Stephen Bongini
Registration No. 40,917

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PTC-103X
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UNITED STATES DEPARTMENT OF COMMERCE
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/191,743	11/13/98	2811	\$910.00	97-CT-174	1	25	4

24

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FT LAUDERDALE FL 33394

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Application Processing Division's Customer Correction Branch within 10 days of receipt. Please provide a copy of the Filing Receipt with the changes noted thereon.

Applicant(s)

RAFFAELE ZAMBRANO, VIAGRANDE (CT), ITALY.

FOREIGN APPLICATIONS-

EPO

97830603.3

11/14/97

TITLE

IN-SITU DEPOSITION AND DOPING PROCESS FOR POLYCRYSTALLINE SILICON
LAYERS AND THE RESULTING DEVICE

PRELIMINARY CLASS: 257

DATA ENTRY BY: SMITH ANNETTE

TEAM: 02 DATE: 12/04/98

(see reverse)